



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: William Andrew Nevin

Serial No.: 10/727,449

Group No: 2818

Filed: 12/04/03

Examiner: Phuc T. Dang

For: METHOD FOR FORMING A CAVITY AND AN SOI IN A SEMICONDUCTOR
SUBSTRATE, AND A SEMICONDUCTOR SUBSTRATE HAVING A BURIED
CAVITY AND/OR AN SOI FORMED THEREIN

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT TRANSMITTAL

1. Transmitted herewith is an amendment for this application.

STATUS

2. Applicant is

☐ a small entity - verified statement:

☐ attached.

☐ already filed.

☒ other than a small entity.

CERTIFICATE OF MAILING (37 CFR 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United State Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Sarah E. Kennedy
(Type or print name of person mailing letter)

Date: 3/21/05


(Signature of person mailing paper)

EXTENSION OF TERM

NOTE: "Extension of Time in Patent Cases (Supplement Amendments)--If a timely and complete response has been filed after a Non-Final Office Action, an extension of time is not required to permit filing and/or entry of an additional amendment after expiration of the shortened statutory period.

If a timely response has been filed after a Final Office Action, an extension of time is required to permit filing and/or entry of a Notice of Appeal or filing and/or entry of an additional amendment after expiration of the shortened statutory period unless the timely-filed response placed the application in condition for allowance. Of course, if a Notice of Appeal has been filed within the shortened statutory period, the period has ceased to run." Notice of December 10, 1985 (1061 O.G. 34-35).

NOTE: See 37 CFR 1.645 for extensions of time in interference proceedings and 37 CFR 1.550(c) for extensions of time in reexamination proceedings.

3. The proceedings herein are for a patent application and the provisions of 37 CFR 1.136 apply

(complete (a) or (b) as applicable)

(a) ___ Applicant petitions for an extension of time under 37 CFR 1.136 (fees: 37 CFR 1.17(a)-(d) for the total number of months checked below:

Extension (months)	Fee for other than <u>small entity</u>	Fee for <u>small entity</u>
___ one month	\$ 120.00	\$ 60.00
___ two months	\$ 450.00	\$225.00
___ three months	\$1,020.00	\$510.00
___ four months	\$1,590.00	\$795.00
___ fifth month	\$2,160.00	\$1,080.00

Fee \$

If an additional extension of time is required please consider this a petition therefor.
(check and complete the next item, if applicable)

___ An extension for ___ months has already been secured and the fee paid therefor of
\$ ___ is deducted from the total fee due for the total months of extension now requested.

Extension fee due with this request \$

OR

(b) X Applicant believes that no extension of term is required. However, this conditional petition is being made to provide for the possibility that applicant has inadvertently overlooked the need for a petition for extension of time.

FEE FOR CLAIMS

4. The fee for claims (37 CFR 1.16(b)-(d)) has been calculated as shown below:

(Col. 1)			(Col. 2)		(Col. 3)		SMALL ENTITY		OTHER THAN A SMALL ENTITY	
CLAIMS REMAINING AFTER AMENDMENT			HIGHEST NO. PREVIOUSLY PAID FOREXTRA		PRESENT RATE		ADDIT. OR RATE		ADDIT. FEE	
TOTAL	47	MINUS	49	=		x 9= \$		x18=	\$	0.00
INDEP.	1	MINUS	3	=		x43= \$		x86=	\$	0.00
FIRST PRESENTATION OF MULTIPLE DEP. CLAIM						+145=\$		+290=	\$	
						TOTAL ADDIT. FEE \$		OR	TOTAL ADDIT. FEE	\$ 0.00

If the entry in Col. 1 is less than entry in Col. 2, write "0" in Col. 3.
 If the "Highest No. Previously Paid For" IN THIS SPACE is less than 20, enter "20".
 If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".
 The "Highest No. Previously Paid For" (Total or Indep.) is the highest number found in the appropriate box in Col. 1 of a prior amendment or the number of claims originally filed.

WARNING: "After final rejection or action (1.113) amendments may be made cancelling claims or complying with any requirement of form which has been made." 37 CFR 1.116(a) (emphasis added).

(complete (c) or (d) as applicable)

- (c) X No additional fee for claims is required.

OR

- (d) Total additional fee for claims required \$_____.

FEE PAYMENT

5. Attached is a check in the sum of \$_____.
- Charge Account No. _____ the sum of \$_____.
- A duplicate of this transmittal is attached.

FEE DEFICIENCY

NOTE: If there is a fee deficiency and there is no authorization to charge an account, additional fees are necessary to cover the additional time consumed in making up the original deficiency. If the maximum, six-month period has expired before the deficiency is noted and corrected, the application is held abandoned. In those instances where authorization to charge is included, processing delays are encountered in returning the papers to the PTO Finance Branch in order to apply these charges prior to action on the cases. Authorization to charge the deposit account for any fee deficiency should be checked. See the Notice of April 7, 1986, (1065 O.G. 31-33).

6. X If any additional extension and/or fee is required, charge Account No. 19-0079

AND/OR

X If any additional fee for claims is required, charge Account No. 19-0079


SIGNATURE OF ATTORNEY

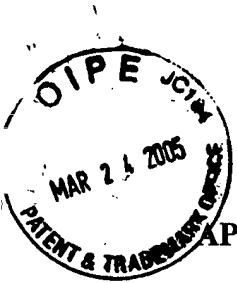
Reg. No.: 33,298

Matthew E. Connors
Type or print name of attorney

Tel. No.: (617) 426-9180
Extension 112

Gauthier & Connors LLP
225 Franklin Street, Suite 3300
P.O. Address

Boston, Massachusetts 02110



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Nevin et al. GROUP: 2818
SERIAL NO: 10/727,449 EXAMINER: Phuc T. Dang
FILED: December 4, 2003
FOR: METHOD FOR FORMING A CAVITY AND AN SOI IN A
SEMICONDUCTOR SUBSTRATE, AND A SEMICONDUCTOR
SUBSTRATE HAVING A BURIED CAVITY AND/OR AN SOI
FORMED THEREIN

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE

In response to the Restriction Requirement of March 2, 2005, Applicants elect Group I, Claims 1-47 drawn to a method for forming a buried cavity in a semiconductor substrate, classified in class 438, subclass 700. A listing of the pending claims is attached hereto.

Examination on the merits is respectfully requested.

Respectfully submitted,

Matthew E. Connors
Registration No. 33,298
Gauthier & Connors LLP
225 Franklin Street, Suite 3300
Boston, Massachusetts 02110
Telephone: (617) 426-9180
Extension 112

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Sarah E. Kennedy

Date: 3/21/05